



Attorney Docket SEL 192

#15/A  
11/14/03  
Mullen

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of Yamazaki et al. )  
Serial No.: 09/610,217 )  
Filed: July 5, 2000 )  
For: Semiconductor Device And )  
Fabrication Method Thereof )  
Art Unit: 2812 )  
Examiner: R. Booth )

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*Rachelle Hamerquist*  
Rachelle Hamerquist  
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Date 12-20-02

01/14/2003 CNDLISH 00000002 501039 09610217  
Commissioner for Patents  
01 FC:1202 Washington, D.C. 20231

December 20, 2002

AMENDMENT A

Sir:

In response to the Office Action of August 22, 2002, a one month extension of time being  
separately submitted, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

29 (Amended). A method of fabricating a semiconductor device having, on the same  
substrate, a pixel TFT disposed in a pixel unit and a driving circuit including a p channel type TFT  
and an n channel type TFT and disposed round said pixel unit, said method comprising:

forming an underlying film over said substrate;

forming a plurality of semiconductor islands over said underlying film;